

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/579,777 Confirmation No. : 5716
First Named Inventor : Hiraku ISHIKAWA
Filed : February 26, 3008
TC/A.U. : 1792
Examiner : Shamim Ahmed

Docket No. : 101994.57726US
Customer No. : 23911

Title : Plasma Film-Forming Apparatus and Plasma Film-
Forming Method

REPLY TO OFFICE ACTION

Mail Stop AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the Office Action dated October 27, 2008.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. *No additional claims fees are due.*

Remarks begin on page 5 of this paper.